



△×				APPROVED	CHECKED	MATERIAL 材料	-	CHAMFER 一般面取	-	QUANTITY 個数					
△×				T. A.	T. A.	TREATMENT 処理	-	FINISHING 仕上	-	-					
△×						TREATMENT CONTACT 処理接点	-	DECENTRATION 偏芯	-						
△×				DESIGNED	DRAWN	OVER 250 UP TO 1000	±0.3	±0.5	±1.0	±0.2	REMARK 適用 (機種名)				
△× 1	ビス変更	16. 12. 01	M. M.			OVER 63 UP TO 250	±0.2	±0.3	±0.6	±0.15		UNIT (mm)	-	VS-1614H1N	
△× 1	彫刻 (VS-1614H1N) 削除	16. 06. 23	T. T.			OVER 16 UP TO 63	±0.1	±0.2	±0.4	±0.1					SCALE
△× 1						OVER 0 UP TO 16	±0.05	±0.1	±0.2	±0.1		DATE	' 13. 05. 24	DRAW NO.	
NO.×箇所	REVISION 訂正事項	DATE	NAME	TOLERANCES	A	B	C	S							